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JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yuan-Sheng Huang

Application No.: 10/004,614 (CONF 8180)

Filed: 11/01/2001

Title: Chamber-reversed dry etching

Attorney Docket No.: 67,200-565

Group Art Unit:
1763

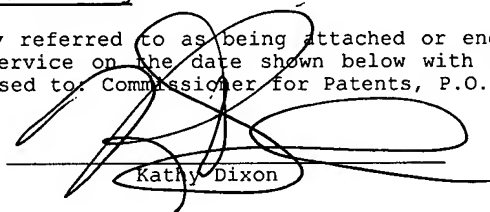
Examiner:
Luz L. Alejandro Mulero

Commissioner for Patents
Alexandria, VA 22313-1450

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: Nov. 30, 2004


Kathy Dixon

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to an Office Action of September 9, 2004, please amend this application as follows: